

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

James M. Holden; William A. McGahan; Richard, A. Yarussi; Pablo I. Inventors:

Rovira; Roger R. Lowe-Webb

Nanometrics Incorporated Assignee:

Title: Apparatus And Method For The Measurement

Of Diffracting Structures

Serial No.: 09/670,000 Filing Date:

September 25

Examiner:

Chih-Cheng Glen Kao

Group Art Unit:

2882

Docket No.:

NAN022 US

Confirmation No.

3656

Santa Clara, California January 10, 2003

COMMISSIONER FOR PATENTS Washington, D. C. 20231

SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT UNDER 37 CFR §1.97(c)

Dear Sir:

Pursuant to 37 C.F.R. § 1.56, §1.97 and §1.98, the Applicants submit for consideration in the above-identified patent reexamination the document listed on the accompanying Form PTO-1449. A copy of the documents is also submitted herewith. The Examiner is requested to make this document of record.

This Information Disclosure Statement is submitted pursuant to 37 CFR §1.97(c) as it is after receipt of a first Office Action on the merits but before mailing of a final Action or Notice of Allowance. Accordingly, a fee is required pursuant to 37 CFR §1.17(p). A Fee Transmittal form (PTO/SB/17) is attached to this submission.

Applicants would appreciate the Examiner initialing and returning the Form PTO-1449, indicating that the information has been considered and made of record herein.

The information contained in this Information Disclosure Statement under 37 C.F.R. §1.555 is to the best of my knowledge and is not to be construed as a representation that: (i) a complete search has been made; (ii) additional information material to the examination of this application does not exist; (iii) the information, protocols, results and the

SILICON VALLEY PATENT GROUP LLP

2350 Mission College Blvd. Suite 360 Santa Clara, CA 95054 (408) 982-8200 FAX (408) 982-8210

01/13/2003 RHEHANKI 00000039 05570000

like reported by third parties are accurate or enabling; or (iv) the above information constitutes prior art to the subject invention.

Via Express Mail Label No. EU 789 864 389 US Respectfully submitted

Michael J. Halbert Attorney for Applicants Reg. No. 40,633

SILICON VALLEY PATENT GROUP LLP

2350 Mission College Blvd. Suiæ 360 Santa Clara, CA 95054 (408) 982-8200 FAX (408) 982-8210